



**MS AF
REPLY UNDER
37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2823**

PATENT
0763-0150P

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IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: LEE, Jun S. Conf.: 5244
Appl. No.: 09/722,583 Group: 2823
Filed: November 28, 2000 Examiner: Kebede, Brook
For: METHOD FOR FABRICATING CAPACITOR OF
SEMICONDUCTOR DEVICE

REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 18, 2003
(Monday)

Sir:

In reply to the Office Action dated April 17, 2003, the due date for response having been extended one (1) month to August 17, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes:

Amendments to the Claims; and
Remarks.

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